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April 18, 2006

Receiver: Examiner Chi H. Pham
Art Unit: 2616

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Sender: Michael J. Ferrazano, Reg. No. 44,105

Re: Information Disclosure Statement (2 pages)
Form 1449 (1 page)
Copy of Examination Report (8 pages)
Application No.: 10/726,895
Attorney Docket No.: GENSP108

Pages Including Cover Sheet: 12

MESSAGE:

CONFIDENTIALITY NOTE

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kobayashi

Attorney Docket No.: GENSP108

Application No.: 10/726,895

Examiner: Pham, Chi H.

Filed: December 2, 2003

Group: 2616

Title: MINIMIZING BUFFER REQUIREMENTS
IN A DIGITAL VIDEO SYSTEM Confirmation No.: 4167

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted by facsimile to fax number 571-273-8300 to the U.S. Patent and Trademark Office on April 18, 2006.

Signed: Linda L. Pollock

Linda L. Pollock

**INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The reference listed in the attached PTO Form 1449, non-U.S. reference attached, may be material to examination of the above-identified patent application. This reference is an examination report dated March 15, 2006 from related European Patent Application No. 04255610.0. Applicant identifies this reference in compliance with his duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make this reference of official record in this application.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure

GENSP108

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Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. GENSP108).

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP



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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. GENSP108	Application No.: 10/726,895
	Applicant: Kobayashi	
	Filing Date December 2, 2003	Group 2616

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
	A1.						
	A2.						
	A3.						
	A4.						
	A5.						

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub- class	Translation	
							Yes	No
	B1.							
	B2.							
	B3.							
	B4.							
	B5.							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1.	Examination Report dated March 15, 2006 from European Patent Application No. 04255610.0.
	C2.	

Examiner	Date Considered
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.